



IFW

In re Application of:

Docket No. 03500.109594.

DAISUKE MIURA, et al.

Application No.: 10/555,614

371(c) Date: November 4, 2005

For: FIELD EFFECT TRANSISTOR, METHOD OF
PRODUCING THE SAME, AND METHOD
OF PRODUCING LAMINATED MEMBER

Date: February 9, 2007

THE COMMISSIONER FOR PATENTS
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Transmitted herewith is a Second Preliminary Amendment in the above-identified application.

☒ No additional fee is required.

The fee has been calculated as shown below

CLAIMS AS AMENDED						
	(2) CLAIMS REMAINING AFTER AMENDMENT		(4) HIGHEST NO. PREVIOUSLY PAID FOR	(5) PRESENT EXTRA	RATE	ADDITIONAL FEE
TOTAL CLAIMS	* 53	MINUS	** 53	= 0	x \$25 \$50	\$0
INDEP. CLAIMS	* 5	MINUS	*** 5	= 0	x \$100 \$200	\$0
Fee for Multiple Dependent claims \$180°/\$360						Previously Paid
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT---						\$0

* If the entry in Column 2 is less than the entry in Column 4, write "0" in Column 5.

** If the "Highest Number Previously Paid For" IN THIS SPACE is less than 20, write "20" in this space.

*** If the "Highest Number Previously Paid For" IN THIS SPACE is less than 3, write "3" in this space.

- ☐ Verified Statement claiming small entity status is enclosed, if not filed previously.
- ☐ A check in the amount of \$_____ is enclosed.
- ☐ Charge \$_____ to Deposit Account No. 06-1205. A duplicate copy of this sheet is enclosed.
- ☒ Any prior general authorization to charge an issue fee under 37 C.F.R. 1.18 to Deposit Account No. 06-1205 is hereby revoked. The Commissioner is hereby authorized to charge any additional fees under 37 C.F.R. 1.16 and 1.17 which may be required during the entire pendency of this application, or to credit any overpayment, to Deposit Account No. 06-1205. A duplicate copy of this paper is enclosed.
- ☐ A check in the amount of \$_____ to cover the fee for a _____ month extension is enclosed.
- ☐ A check in the amount of \$_____ to cover the Information Disclosure Statement fee is enclosed.
- ☒ Applicants' undersigned attorney may be reached in our Costa Mesa, California office by telephone at (714) 540-8700. All correspondence should continue to be directed to our address given below.

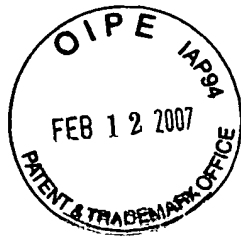
Respectfully submitted,



Damond E. Vadnais
Attorney for Applicants
Registration No.: 52,310

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Facsimile: (212) 218-2200

03500.109594.



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)	
	:	
DAISUKE MIURA, et al.)	
	:	
Application No.: 10/555,614)	
	:	
371(c) Date: November 4, 2005)	
	:	
For: FIELD EFFECT TRANSISTOR,)	
METHOD OF PRODUCING	:	
THE SAME, AND METHOD)	
OF PRODUCING LAMINATED	:	
MEMBER)	February 9, 2007

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

SECOND PRELIMINARY AMENDMENT

Sir:

Prior to examination on the merits, please amend the above-identified
application as follows: